

Hierarchical and Re-entrant Micro/Nano-structures for Superhydrophobic Surfaces with Extremely Low Hysteresis

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We report a low-cost, scalable way of fabricating hierarchical micro/nano structures with re-entrant shapes for superhydrophobic surfaces with extremely low hysteresis. Superhydrophobic surfaces have numerous applications in self-cleaning [1, 2], anti-fouling [3], anti-freezing [4] and heat transfer enhancement [5]. Surface nanostructures reduce the actual contact area between a solid surface and liquid droplet—thus contact angle increases and sliding angle decreases [6]. In contrast to most hierarchical geometries with simple micropillar structures that do not prevent water from falling into gaps, re-entrant structures minimize the droplet contact area by repelling water from contacting the micropillar sidewalls [7]. We combined the hierarchical micro/nanostructuring with re-entrant profiles for the micropillars (Fig. 1a-d) to draw advantage of both effects. Re-entrant microstructures were produced using conventional silicon microfabrication, and silicon nanopillars (SiNPs) were patterned over these microstructures by metal-assisted-chemical etching (MACeTch) [8]. We have developed a unique method of treating rough sidewall profiles resulting from a DRIE process that enables complete coverage of SiNPs on patterned microstructures. Our results (figure 1e) indicate that tuning the re-entrant geometry (area fraction) drives hydrophobicity, which is further strengthened by the SiNPs that prevent hysteresis by reducing the sliding angle well below the 2° criterion for superhydrophobicity. We have demonstrated water contact angle of 170° and minimum hysteresis with a sliding angle as low as 0.5° .

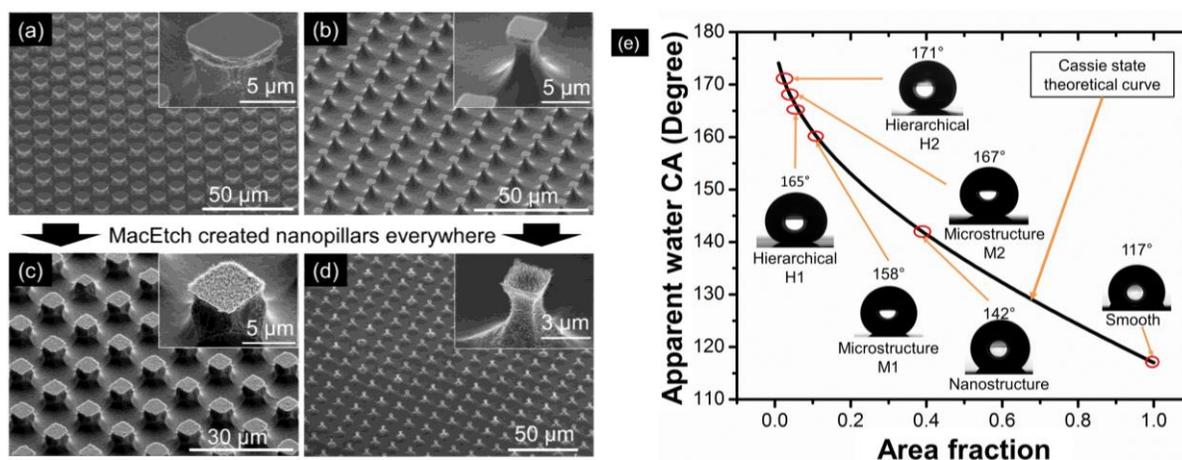


Figure 1. SEM images of (a & b) microfabricated re-entrant microstructures and (c & d) corresponding hierarchical micro/nano structures created by MACeTch. (e) Apparent water contact angle measurements from wetting studies

References

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